

03500.017976



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Tetsuro NAKAMURA et al.) Examiner: Unassigned
Application No.: 10/806,157) Group Art Unit: 1753
Filed: March 23, 2004) Confirmation No.: 2170
For: METHOD OF PRODUCING)
PHOTOVOLTAIC DEVICE) August 30, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the Japanese patent documents and of the Sannomiya et al. and Inoue et al. articles are also enclosed.

The Japanese patent documents are discussed at pages 3 to 5 of the specification. U.S. Patent Nos. 5,804,466, 6,660,931, and 6,465,727 are believed to be English-language counterparts of Japanese patent document numbers 10-140373, 2002-237606, and 2001-339079, respectively.

The Sannomiya et al. and Inoue et al. articles are discussed at page 3 of the subject specification.

The Examiner's attention is also directed to the following co-pending U.S. patent application. A copy of this application is also enclosed.

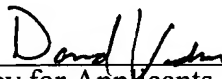
<u>U.S. Patent Application No.</u>	<u>Filing Date</u>	<u>Applicants</u>
10/833,125	April 28, 2004	Takaharu Kondo et al.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

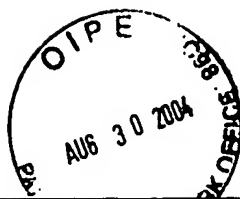
Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Damond E. Vadnais
Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
DEV/eab
DC_MAIN 175988



FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) August 30, 2004				ATTY DOCKET NO. 03500.017976		APPLICATION NO. 10/806,157	
				APPLICANT Tetsuro NAKAMURA et al.			
				FILING DATE March 23, 2004		GROUP 1753	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US-6,465,727 B2	10/15/2002	Maruyama et al.	136	256	
		US-6,660,931 B2	12/09/2003	Toyama et al.	136	256	
		US-5,804,466	09/08/1998	Arao et al.	438	95	
		US-6,613,603 B1	09/02/2003	Sano	438	72	
		US-6,488,995 B1	12/03/2002	Nishimoto et al.	427	574	
		US-6,399,873 B1	06/04/2002	Sano et al.	136	249	
		US-6,303,945 B1	10/16/2001	Saito et al.	257	64	
		US-6,635,899 B2	10/21/2003	Saito et al.	257	64	
		US-6,344,608 B2	02/05/2002	Kariya et al.	136	257	
		US-6,653,165 B2	11/25/2003	Kondo et al.	438	73	
		US-6,706,336 B2	03/16/2004	Kondo et al.	427	588	
		US-6,172,296 B1	01/09/2001	Iwasaki et al.	136	256	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		4-119843	04/21/1992	Japan			Abstract
		3273294	02/01/2002	Japan			Abstract
		2002-237606	08/23/2002	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Sannomiya, H., et al., "a-SiC/a-Si/a-SiGe MULTI-BANDGAP STACKED SOLAR CELLS WITH BANDGAP PROFILING," <i>Technical Digest of the International PVSEC-5</i> , Kyoto, Japan, 1990. Energy Conversion Laboratories, SHARP Corp. Pp. 387-390.					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) August 30, 2004				ATTY DOCKET NO. 03500.017976		APPLICATION NO. 10/806,157	
				APPLICANT Tetsuro NAKAMURA et al.			
				FILING DATE March 23, 2004		GROUP 1753	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US-6,123,824	09/26/2000	Sano et al.	205	124	
		US-6,472,248 B2	10/29/2002	Shiozaki et al.	438	97	
		2003/0075717 A1	04/24/2003	Kondo et al.	257	64	
		2003/0104664 A1	06/05/2003	Kondo et al.	438	200	
		2003/0028486 A1	02/06/2003	Nakamura	705	50	
		2002/0117661 A1	08/29/2002	Kondo et al.	257	21	
		2003/0153165 A1	08/14/2003	Kondo et al.	438	478	
		2003/0019519 A1	01/30/2003	Toyama et al.	136	256	
		2002/0002993 A1	01/10/2002	Maruyama et al.	136	258	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		2001-339079	12/07/2001	Japan			Abstract
		2001-152930	06/05/2001	Japan			Abstract
		10-140373	05/26/1998	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Inoue, Y., et al. "Optical confinement effect in a-SiGe solar cells on stainless steel substrates," 29p-MF-2, 51st Academic Lecture by the Applied Physics Society of Japan, Fall 1990. P. 747.					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.